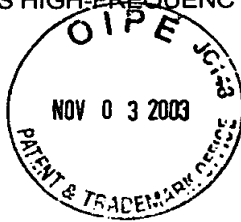


In re Application of: Takahiro OHNAKADO  
 Application No. 09/911,581  
 Filed: July 25, 2001  
 For: SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE

Mail Stop AF  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450



Corres. and Mail  
**BOX AF**

Sir:

- ☐ Small entity status is claimed for this application under 37 CFR 1.27.
- ☐ Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- ☐ Other:
- ☐ Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		none			\$ 0.00		\$ 0.00	
	subtract time extension fee previously paid	none			(\$ 0.00)		(\$ 0.00)	
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDIT. CLAIM FEE	RATE	ADDIT. CLAIM FEE
TOTAL		MINUS		=0	x 9=	\$	x 18=	\$
INDEPENDENT		MINUS		=0	x 43=	\$	x 86=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 145=	\$	+ 290=	\$
<b>TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT</b>					TOTAL	\$	TOTAL	\$

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Jeffrey A. Wyand, Reg. No. 29,458  
 LEYDIG, VOIT & MAYER  
 700 Thirteenth Street, N.W., Suite 300  
 Washington, DC 20005-3960  
 (202) 737-6770 (telephone)  
 (202) 737-6776 (facsimile)

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Date: November 3, 2003  
 JAW/tps  
 Amendment or ROA Transmittal (Revised 10/2/03)



**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2815**

**PATENT**  
Attorney Docket No. 401308

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Takahiro OHNAKADO

Application No. 09/911,581

Art Unit: 2815

Examiner: N Drew Richards

Filed: July 25, 2001

For: SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE

**RESPONSE TO OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 4, 2003, please enter the following amendments and consider the following remarks.

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